



1763
f

PATENT
Customer No. 22,852
Attorney Docket No. 07553.0017

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Mitsuru ISHIKAWA *et al.*)
Application No.: 09/696,232) Group Art Unit: 1763
Filed: October 26, 2000) Examiner: Allan W. OLSEN
For: ETCHING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION

In reply to the Office Action mailed February 27, 2004, the period for response having been extended to June 27, 2004 by a request for extension of one month and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.